

<b>Notice of References Cited</b>	Application/Control No. 09/775,715	Applicant(s)/Patent Under Reexamination ABROL ET AL.	
	Examiner Chongshan Chen	Art Unit 2172	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-2002/0099700	07-2002	Li, Wen-Syan	707/5
	B	US-6,480,837	11-2002	Dutta, Rabindranath	707/3
	C	US-2001/0003185	06-2001	Lee et al.	707/102
	D	US-6,434,550	08-2002	Warner et al.	707/3
	E	US-6,269,368	07-2001	Diamond, Theodore G.	707/6
	F	US-6,067,539	05-2000	Cohen, Gideon David	707/2
	G	US-5,847,708	12-1998	Wolff, Gregory J.	345/764
	H	US-6,347,313	02-2002	Ma et al.	707/3
	I	US-6,006,221	12-1999	Liddy et al.	707/5
	J	US-6,411,952	06-2002	Bharat et al.	707/5
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.